

Notice of References Cited		Application/Control No. 10/707,979	Applicant(s)/Patent Under Reexamination DENTON ET AL.	
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*	B	US-7,464,147 B1	12-2008	Fakhouri et al.	709/223
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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